I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450, on

(Signature & date)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

November 5, 2003

Delehanty et al.

Group Art Unit:

Serial No. 10/605,610:

Examiner:

Filed: 10-13-03

International Business Machines Corporation

2070 Route 52

Hopewell Junction, NY 12533

TITLE: PLANARIZATION SYSTEM AND METHOD USING A CARBONATE CONTAINING FLUID

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

Pursuant to the duty of disclosure set forth in 37 C.F.R. 1.56, and further pursuant to the provisions of 37 C.F.R. 1.97 and 1.98, applicants hereby respectfully submit copies of the non-US patents and publications as listed on Form PTO-1449, are attached hereto.

In citing these documents, no representation is made nor intended as to the pertinency or nonpertinency of the art, that better art than that listed is not available, or that other art is not applicable.

No fee is believed to be due for this submission. If any fees are required, however, the Commissioner is hereby authorized to charge such fees to Deposit Account No. 09-0458.

Respectfully submitted,

Todd M. C. Li

Registration No. 45,554

Telephone No. 845-894-6919

INFORMATION DISCLOSURE CITATION					Docket Number (Optional) FIS9-2002-0		Application Number 10/605,610		
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